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UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Akira YAMANOUE et al.

Group Art Unit: 2811

Serial No.: 10/694,766

Examiner: Nitin Parekh

Filed: October 29, 2003

Confirmation No.: 5286

For: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING
THE SAME

Attorney Docket Number: 032069

Customer Number: 38834

AMENDMENT AFTER FINAL REJECTION

MAILSTOP: AF

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

Date: July 28, 2005

Sir:

In response to the Office Action dated April 28, 2005, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims are reflected on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.